

# Roll to Roll (R2R) Processing Technology Assessment

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# 40 1. Introduction to the Technology/System

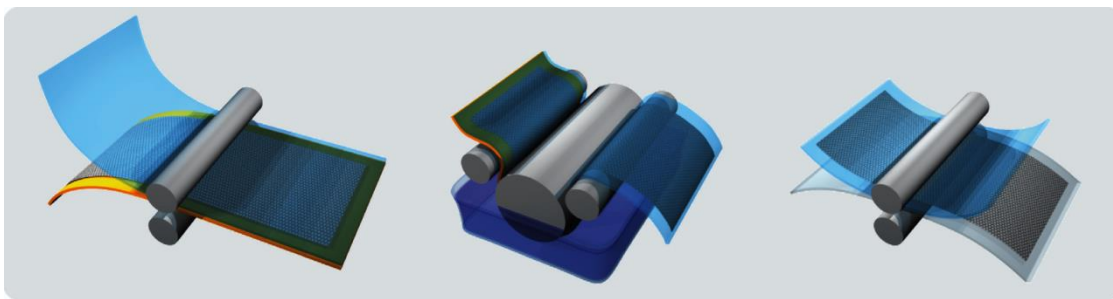
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## 42 1.1. Introduction to R2R Processing

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44 Roll-to-roll (R2R) is a family of manufacturing techniques involving continuous processing of a flexible  
45 substrate as it is transferred between two moving rolls of material [1]. R2R is an important class of  
46 substrate-based manufacturing processes in which additive and subtractive processes can be used to  
47 build structures in a continuous manner. Other methods include sheet to sheet, sheets on shuttle, and  
48 roll to sheet; much of the technology potential described in this R2R Technology Assessment conveys to  
49 these associated, substrate-based manufacturing methods [2]. R2R is a “process” comprising many  
50 technologies that, when combined, can produce rolls of finished material in an efficient and cost  
51 effective manner with the benefits of high production rates and in mass quantities. High throughput and  
52 low cost are the factors that differentiate R2R manufacturing from conventional manufacturing which is  
53 slower and higher cost due to the multiple steps involved, for instance, in batch processing. Initial capital  
54 costs can be high to set up such a system; however, these costs can often be recovered through  
55 economy of scale. Figure 1 illustrates an example of R2R processing of a state-of-the-art nanomaterial  
56 used in flexible touchscreen displays. [3]

57



58

**Figure 1 – R2R processing of graphene film for flexible touchscreen displays [3].**

59 Today, R2R processing is applied in numerous manufacturing fields such as flexible and large-area  
60 electronics devices, flexible solar panels, printed/flexible thin-film batteries, fibers and textiles, metal  
61 foil and sheet manufacturing, medical products, energy products in buildings, and membranes to name  
62 a few. In the field of electronic devices, R2R processing is a method of producing flexible and large-area  
63 electronic devices on a roll of plastic or metal foil. Substrate materials used in R2R printing are typically  
64 paper, plastic films or metal foils. Stainless steel is sometimes used because it is durable and has a high  
65 temperature tolerance [4]. The global flexible electronics (flexible display, flexible battery, flexible

66 sensor, flexible memory and thin film photovoltaic (PV)) market revenue was estimated to grow from  
67 \$3.4 billion in 2013 to \$13.23 billion in 2020 at a compound annual growth rate (CAGR) of 21.73% from  
68 2014 to 2020. The consumer electronics market is expected to grow at a CAGR of 44.30% and is  
69 supported by advancements in flexible displays, flexible sensors and thin-film solid-state batteries that  
70 can be produced using R2R processes. [1] [5]

71  
72 Further development of R2R production capabilities that are energy efficient, low environmental impact  
73 and lower cost and that are employed to manufacture technologies and products for clean energy  
74 applications will have a “global impact” in the manufacturing industry. There are huge savings in energy  
75 just from higher throughputs since the tools and equipment used in R2R manufacturing (per unit area of  
76 manufactured roll) are using less energy for a much shorter period of time relative to conventional  
77 manufacturing processes. Additionally, efficiencies are obtained from more efficient deposition  
78 processes, for example, that would provide additional savings in energy. Breakthroughs that will have  
79 high impact, and therefore high value, are in the nano-manufacturing community. [1]

80  
81 The R2R Tech Assessment reviews current state-of-the-art technologies, clean energy applications, and  
82 industry investments to categorize advances in R2R manufacturing in the areas of metrology,  
83 equipment, carriers/webs, substrate materials, process improvement, alternative applications and other  
84 possible innovations. These efforts will serve to enable and maintain the competitive nature of R2R  
85 manufacturing for the domestic U.S. industry.

86  
87 **1.2. R2R Processing Mechanisms**

88 Silicon wafers, cadmium-telluride solar cells, battery electrodes, fuel cell membranes, and high  
89 performance window films are just a few examples of materials that have clean energy applications and  
90 are characterized by a two-dimensional functional surface, often with one or more coated or deposited  
91 layers. Not surprisingly, these materials are often made using similar processes—namely continuous roll-  
92 to-roll, belt-fed, or conveyor-based processes that enable successive steps to build a final construction  
93 at high throughput.

94  
95 As a comparison of the variety of processes that can be used for R2R manufacturing, a brief description  
96 of each are provided here.

- 97  
98 • **Deposition** – Evaporation, sputtering, and chemical vapor deposition (CVD) can all be easily  
99 implemented in R2R processing. Multilayer sputtering systems are the most common. The entire  
100 roll is loaded into a vacuum system where it is relatively easy to sputter or evaporate different  
101 materials onto a substrate without crosstalk as shown in Figure 2. This is more difficult in CVD  
102 where reactive gas barriers are needed within the vacuum system. [7] When the substrate  
103 moves past the sputtering source, the deposition rate of material varies. The processing rate  
104 influences the thickness and sequence of layers in a multilayer coating which also depends on  
105 rotation speed, initial position and orientation of the substrate. CVD can be used to deposit  
106 materials on a continuous roll of flexible metal foils, plastics, and other materials in place of  
107 individual substrates. This technology has been used for superconductor tape production and  
108 nanomaterial synthesis and is growing in popularity for thin film solar deposition.

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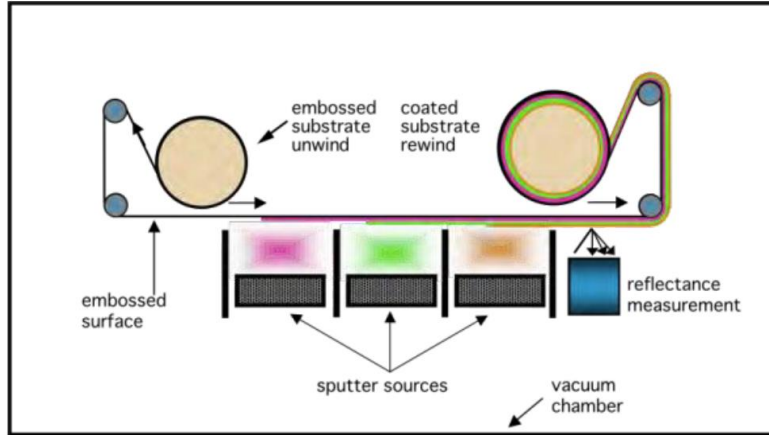


Figure 2 – Inline vacuum coater and sputtering process [1].

- Gravure** - A type of printing process which involves engraving the image onto an image carrier. In gravure printing, the image is engraved onto a cylinder because, like offset printing and flexography, it uses a rotary printing press. The entire patterned cylinder is covered with ink as shown in the upper left corner of Figure 3. The excess ink is doctored off, leaving ink in the cup-shaped engraved pattern. The plate cylinder is brought into contact with the impression cylinder to transfer the ink to the substrate. [8] Once a staple of newspaper photo features, the process is still used for commercial printing of magazines, postcards, and product packaging.
- Flexographic Printing** - A form of printing process which utilizes a flexible relief plate as shown in the upper right corner of Figure 3. It is essentially a modern version of letterpress which can be used for printing on almost any type of substrate, including plastic, metallic films, cellophane, and paper. It is widely used for printing on the non-porous substrates required for various types of food packaging. Only the raised area in the pattern cylinder is inked and the pattern is transferred to the substrate. [8]
- Flatbed and Rotary Screen Printing** – In flatbed printing, a squeegee, moves relative to a mesh, then forces the ink through the open area and onto the substrate. The wet layer thickness is defined by the thickness as well as the open area of the mesh and generally relative thick wet layers can be achieved (10–500  $\mu\text{m}$ ). [9] In rotary screen printing, substrate moves through past the squeegee forcing onto the substrate. Both processes are illustrated lower half of Figure 3.

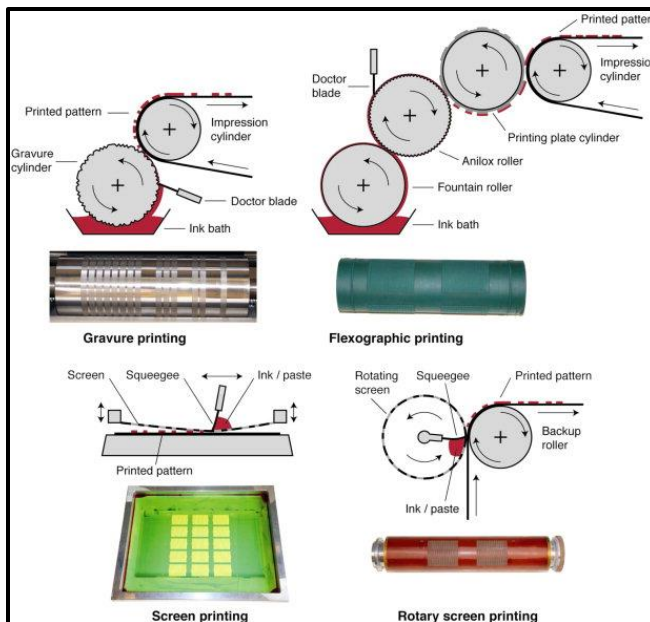


Figure 3 - R2R Processing diagrams for organic electronics/thin films [6].

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- Imprint or Soft Lithography** – In soft lithography (e.g. self-aligned imprint lithography (SAIL)), multiple mask levels are imprinted as a single three dimensional (3-D) structure as shown in Figure 4. The photopolymer layer is heated above its glass transition temperature to allow it to flow into the crevices of the stamp. The stamp/ polymer sandwich is cured with ultraviolet (UV) light as the polymer cools and hardens, allowing the stamp to pull off cleanly. The process is completed with standard wet and dry etch processes, leaving an accurately reproduced 3-D, high resolution pattern on the substrate. The technology is called self-aligning because the mask would deform with the substrate during the embossing heat treatment step. [10]

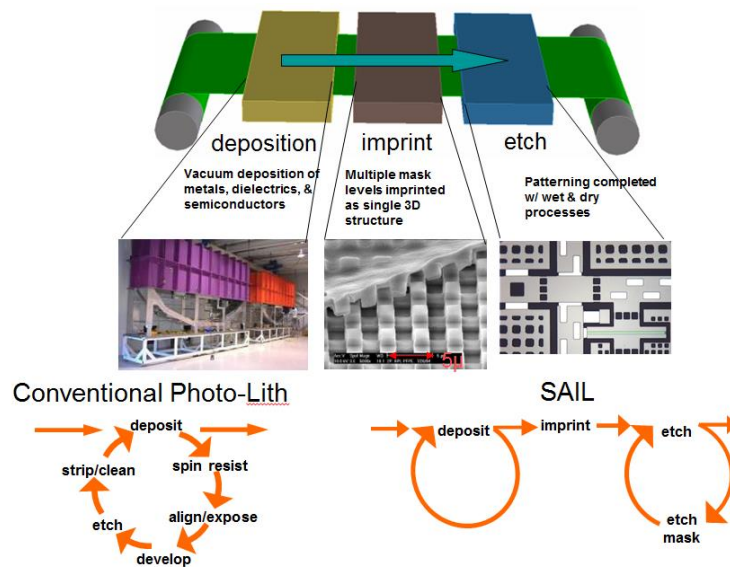


Figure 4 – Self-Aligned Imprint Lithography [11].

- Laser Ablation** - A technique that would eliminate both the photoresist coating and wet etching steps is called laser photoablation and is illustrated in Figure 5. This technique is used to write directly into a polymer layer using a high powered laser. The photoablation works by breaking molecular bonds in polymer layer, fracturing the polymer into shorter units that are “kinetically

206 ejected” upon removal. The amount of material  
 207 ejected can be tuned by adjusting the  
 208 wavelength, energy density and pulse width of  
 209 the xenon-flouride (XeF) excimer laser (a form of  
 210 UV laser which is commonly used in the  
 211 production of microelectronic devices) used for  
 212 ablation and is capable of reproducing ablation  
 213 depth to within 0.1 μm across large areas of the  
 214 substrate. Examples of ablatable polymers are  
 215 polyimides (e.g “Kapton<sup>®</sup>”) and polyethylene  
 216 terephthalate (PET) (e.g Mylar<sup>®</sup>), which are also  
 217 commonly used substrates in flexible electronics  
 218 [10].

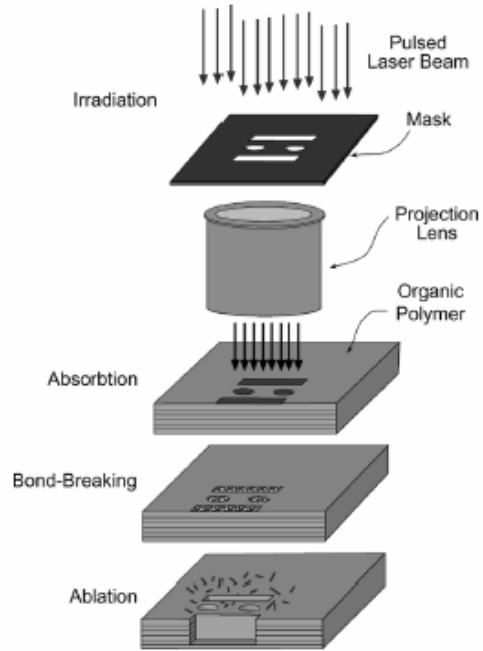
221 • **Offset Printing** - A commonly used technique in  
 222 which the inked image is transferred (or “offset”)  
 223 from a blanket cylinder that bridges the plate  
 224 cylinder and the substrate. The pattern is  
 225 transferred to the blanket (usually made of  
 226 rubber), and then transferred to the substrate  
 227 [8].

228 • **Inkjet Printing** - While laser ablation may be called a subtractive technique, inkjet printing can  
 229 be considered an additive technique. Rather than your home, graphics-oriented inkjet printer,  
 230 an array of piezoelectric print heads are required for the deposition of conducting organic  
 231 solutions at precise locations [10].

233 Table 1 provides a comparison between some of these different printing methods in terms of their  
 234 theoretical capacity and practical applicability for large-scale R2R production.

237 **Table 1** – Comparison between different printing methods in terms of their theoretical capacity and practical  
 238 applicability for large-scale R2R production

Printing Method	Speed	Wet Thickness (μm)	Resolution (μm)	Start/Stop	Complexity	Applicability
Flatbed Screen Printing [5]	Low	5-100	100	Yes	Low	Limited
Rotary Screen Printing [5]	High	3-500	100	Yes(a)	Medium	Very good
Inkjet Printing [5]	Medium	1-5	<50	Yes	High	Limited, materials must be jettable
Flexography [5]	Very high	1-10	<50	Yes(a)	Medium	Very good



**Figure 5** – Schematic of the laser ablation process [10].

<b>Imprint or soft lithography [20]</b>	High (>5 meters/min)		0.1 (100 nm demonstrated)			New technology
<b>Laser ablation [20]</b>	Low		~10			Thermal effect sensitivity
<b>Gravure [12]</b>	High		>0.07 (70 nm demonstrated)			Very Good

239 (a) - Stopping should be avoided. Risk of registration lost and drying of ink in anilox cylinder. Short run-in length

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 241 Substrates that are used in R2R processing may be made of a variety of materials depending on the  
 242 application and processing steps involved in fabrication. Plastic films are desirable for their  
 243 transparency, flexibility and toughness, but are often susceptible to degradation and dimensional  
 244 distortion at high temperature [10]. Where transparency is not required, stainless steel foils may be  
 245 chosen as they tolerate higher temperatures than plastics. Other materials, such as aluminum and  
 246 copper alloys, may also be used.

247  
 248 Circuit patterns may be formed on the flexible substrate in a variety of ways. Some such production lines  
 249 employ inkjet technology to deposit material onto the substrate. This process is similar to how an inkjet  
 250 printer deposits ink onto paper. Some facilities employ photolithography, using light to etch away a  
 251 pattern on the substrate that may then be filled with another material. Other techniques using  
 252 ultraviolet light, lasers, and so on, may also be used to imprint the substrate with electrical circuitry.

253  
 254 A variety of other manufacturing steps may also be accomplished using R2R processing. In addition to  
 255 laying down circuit patterns, such steps as die cutting, laminating, placing labels, cleaning, and more  
 256 may be performed. Heat sealing and application of a variety of coatings may also be included in a roll-to-  
 257 roll processing operation.

258

## 259 **2. Technology Assessment and Potential**

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### 261 **2.1. Benefits of R2R Manufacturing**

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263 Benefits of R2R processing include high production rates and yields. This technique can help reduce the  
 264 cost of manufacturing through economy of scale as it allows devices to be fabricated automatically in  
 265 mass quantities. Although initial capital costs can be high to set up such a system, these costs can often  
 266 be recovered through the economic advantages during production [13]. For conventional sheet-fed  
 267 systems, sheet handling and off-line drying consume a good portion of the overall cycle time.  
 268 Continuous production can be achieved on a roll-to-roll system due to in-line hot air drying and  
 269 sophisticated web-tension controls.

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### 271 **2.2. R2R Processing Applications**

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273 The R2R technology has evolved to support a wide range of industrial applications used for both  
 274 traditional and “cutting-edge” products [1]. Two flexible thin film products made by R2R processing are  
 275 shown in Figure 6.



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**Figure 6** – Example battery electrode (left) and thin film (right) photovoltaic materials. Photo from David Wood, Oak Ridge National Laboratory (L) and Warren Gretz, NREL

The major technology areas with clean energy applications that have been produced using R2R manufacturing are as follows:

- Flexible electronics - super-capacitors, electronic circuits, radio frequency identification (RFID) chips, organic light emitting diodes (OLEDs), displays, sensors, etc.
- Flexible photovoltaics - Copper-Indium Gallium-Selenide Photovoltaic (CIGS PV) and other flexible PV products (Figure 6),
- Printed/flexible thin-film batteries - laminar Lithium-ion, etc. (Figure 6),
- Fuel cells - laminar solid oxide fuel cells (SOFC), proton exchange membranes (PEM), membrane electrode assemblies and gas diffusion media,
- Multilayer capacitors (MLC), (i.e. dielectrics such as NPO/X5R/XR7/Relaxer/etc.)
- Thick and thin-film substrates ( $Al_2O_3$ , AlN,  $Si_3N_4$ , SiC, GaN, MgO, ZrO, etc.)
- Thick-film sensor materials (temperature sensors, positioners, transducers, e.g. negative temperature coefficient thermistors, piezoelectric/lead zirconate titanate (PZT), active/passive, selective gas)
- Fabric (clothing textiles, fiber reinforce mat/fiberglass/carbon/polymer)
- Anti-static, release, reflective and anti-reflective coatings (glass, Mylar®, polyethylene)
- Barrier Coatings (thermal and environmental)
- Building products, films (electro-chromic, reflectives, etc.), composite structural members, etc.
- Metal ribbon (transformer “coils”, etc.)
- Paper industry
- Chemical separation membranes (reverse osmosis, catalyst)

All are considered to be 2-D processed using continuous sheet-based manufacturing lines which have been developed in a variety of forms. Figure 7 shows two generic R2R processes of screen printing and tape casting. R2R lines are used when a continuous sheet, or “web”, can be conveyed on the line in an unsupported fashion. In addition to the web speed, the tension of the web is typically controlled to ensure that the motion of the web across and around a multiplicity of rollers is done in a way that does not cause stretching or wrinkling of the web. Belt-fed lines are similar and are used when support of the web during processing is required, for example during high-temperature process steps. Float lines are



323 similar in concept and allow long sheets of material such as glass to be processed while moving and  
324 supported on a liquid surface. Finally, conveyors are used for cases such as silicon photovoltaic wafers  
325 wherein discrete parts are processed in a continuous fashion, although much processing is accomplished  
326 using batch process methods.

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330 **Figure 7** - (Left) screen printing and (right) tape casting.  
331 Photos from M. Richards, Versa Power Systems  
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333 Many different permutations of processes are used on these continuous lines—too many to review in  
334 detail. Instead, broad categories of processes are highlighted below. A high level discussion on various  
335 printing/coating/deposition mechanisms was already covered in section 1.2. Most of the materials of  
336 interest involve some kind of coating or deposition—often several in series—to create functional layers  
337 and surfaces [7]. These additive processes are categorized by the pressure at which the coating is  
338 applied: either at atmospheric (room) pressure or in a vacuum. Atmospheric coatings take several  
339 generic forms. Roll coating is characterized by two or more rollers, in a wide variety of configurations,  
340 being used to “pick up” a thin layer of liquid from a bath and apply it to a surface of a web. Knife coating  
341 is similar to roll coating, wherein a stationary bar or rod—the “knife”—, commonly known as a “Dr.  
342 Blade” is set to a certain stand-off distance from the web and is used to control the amount of liquid  
343 deposited onto the web from a reservoir in process referred to as tape casting [14]. Figure 8 illustrates  
344 this process.

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**Figure 8** - Traditional, current technology “Laboratory-Scale” Tape Caster and “Dr. Blade”, manufactured by HED  
used to deposit thick-film slurry on moving web “substrate.”

350 Various masks or other limits to the location or position of the coated liquid can be employed, as in  
351 screen printing. A wide variety of techniques are generically referred to as die coating, characterized by  
352 a sheet of coating being dropped or laid onto the web. The die comprises two or more typically metal  
353 plates with machined flow-fields between to enable the creation of a highly uniform sheet of coating.  
354 And finally, for the atmospheric coatings, spray methods are often employed using one or an array of  
355 spray heads to coat the web from side to side. Low temperature systems are used most often, including  
356 a variety of jet methods as well as systems where the head is ultrasonically actuated to break up  
357 droplets and particles into a very fine spray. In cases where the substrate or base material can withstand  
358 the thermal load, high temperature sprays can be used, including electrical arc and plasma-based  
359 methods. In almost all cases of liquid coatings applied under atmospheric pressure, some kind of drying  
360 and/or curing of the coating is required. Drying is used to drive off solvents that are used to make a  
361 coatable mixture but are not desired in the final layer and is typically accomplished using heated gas or  
362 infrared heat sources. Curing is a post-treatment process to finalize the chemical or morphological  
363 nature of the coating by irradiation with an energy source such as infrared or ultraviolet lamps, or an  
364 electron beam.

365  
366 Vacuum coating techniques incorporate a number of vapor deposition technologies, such as sputtering  
367 and evaporative coating. These processes are typically used for very thin coatings—usually less than a  
368 micrometer in thickness, referred to thin-film processes [15]. Importantly, when vacuum processes are  
369 used in continuous production, complicated and expensive line equipment must be employed to allow  
370 movement of the web while still maintaining very low pressure. Several mechanical processing steps are  
371 also used including cutting or sawing processes, texturing of the surface, and creation of electrical  
372 junctions. Figure 9 shows a reel-to-reel vacuum deposition process.



373  
374 **Figure 9** - Reel-to-reel vacuum deposition line.  
375 Photo from Global Solar Energy, NREL 13414  
376

377 Many of the described processes have been available to the manufacturer for many, i.e. > 40 years.  
378 An idealized R2R manufacturing process with the essential steps from the raw materials to the  
379 finished product is illustrated in Figure 10. However, because of demand for increased process  
380 competitiveness, new applications and equipment, researchers have continued to evolve the wide  
381 range of processes to meet innovation challenges. Whereas in the 1970s one was barely able to  
382 print 25  $\mu\text{m}$  wide lines and traces on a 250  $\mu\text{m}$  thick substrate, today, it has been demonstrated that  
383 investigators can routinely print sub-200 nm features in a continuous web [16].

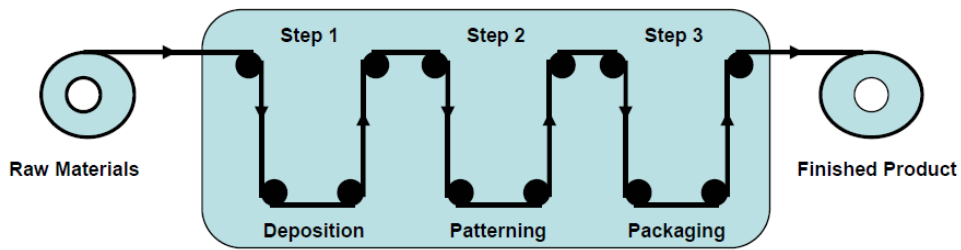


Figure 10 - Idealized Roll-to-Roll manufacturing process flow [4]

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### 2.3. Challenges to R2R Manufacturing

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The following summarizes some of the challenges faced by industry when considering R2R

406

manufacturing to produce a technology.

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- In order to succeed as a viable manufacturing alternative, R2R processing technologies need to show a dramatic reduction in cost compared to the traditional technologies [10].
- In most cases, the low cost of R2R manufacturing can only be exploited if the facility is operating close to the full production capacity. In R2R processing the challenge is in the limited variety of products that can be run, and the large capacity of any one facility. The variety of products is limited because the sequence of process steps is fixed. This is in contrast to a typical semiconductor fabrication, where the individual pieces of automated equipment stand alone and multiple process sequences are supported. The advantage of multiple process sequences is that a much larger number of products can be manufactured in the facility helping to keep it fully utilized. [7]
- The other challenge is that the low cost of R2R results from the rapid process time, that means that even more production is needed to fully utilize the facility. Therefore an application must have very high volumes and /or large areas to utilize a R2R fabrication supporting a single process sequence. Solar cells and display films are two applications where the devices are large area and the potential markets are also very large [7].

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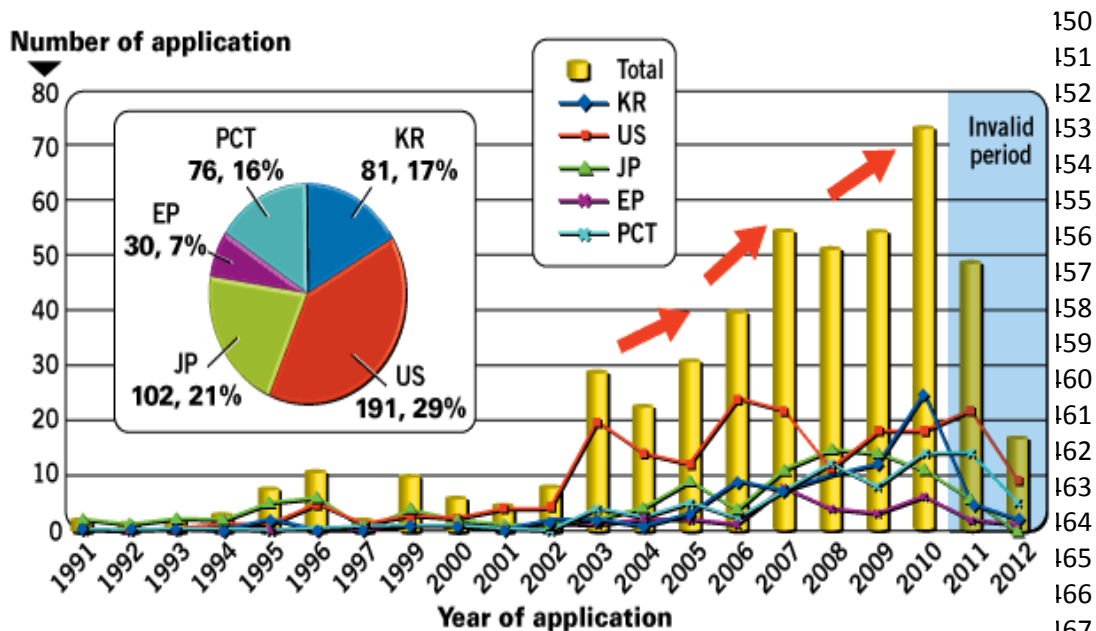
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- The infrastructure for manufacturing large area flexible displays does not yet exist, so factories wishing to incorporate R2R processing technologies would have to deal with very high start-up costs due to custom-built tools [10] [17].
- As R2R manufacturing processes transcend from fundamental science to laboratory-scale production platforms within academia and industry, the transition to pilot-scale production is hampered by several factors that can benefit from standards. The resulting delay in the commercialization cycle includes losses resulting from incoming materials variations, process technologies, process tolerances, equipment and operator inconsistencies, and lot-to-lot variations, making it extremely costly and difficult to scale to R2R production capacity. Standards are necessary to assist in the translation of discrete processes to an integrated manufacturing flow [1].

**2.4. Public and private activities to date**

The “additionality” for R2R manufacturing resides in many entities. Government agencies (DOD Army, NSF, DOE Offices), national labs (LBNL, ORNL, NREL, PNNL, etc.) large companies (PlasticLogic, POLYIC, Philips), and academia (University of Mass Amherst, University of Kentucky, Binghamton University) have current interests in energy saving technologies that can be produced by R2R manufacturing processes.

A 2013 report by Information Handling Services (IHS) stated that “of 483 roll-to-roll processing technology patents, 23 flexible OLED-related U.S. published/issued patents and 9 international patents were extracted as key patents. Looking at the application trend of 483 patents (Figure 11) on roll-to-roll processing technology, the number of applications has continuously increased since mid-2000s, and many were applied in the U.S. Major applicants include 3M Innovative Properties, SiPix Imaging, Fuji Film, and General Electric. Amid vigorous developments of roll-to-roll processing technologies, competition among companies in the U.S., Japan, and South Korea gets increasingly fierce.” [18]



**Figure 11 - Roll-to-roll Processing Technology Patent Application Trends by Year/Country**

470  
 471 Although R2R processes have been used in various applications for decades, very few patents have been  
 472 filed until the early 2000’s, as can be seen in Figure 11, and is steadily increasing over the last decade.  
 473

474 **2.4.1. Current Research Efforts by DoD**

475 The combined services, including the Air Force Research Laboratory (AFRL), the Army Research  
 476 Laboratory (ARL) and the Naval Research Laboratory (NRL ), have all been actively cooperating in  
 477 research on micro-electronics, focused on flat panel displays [19].  
 478

- 479 • More recently, ARL has sponsored research in thin film transistor arrays for displays and digital  
 480 x-ray detectors. Currently, ARL manages The Flexible Display Center (FDC), based out of Arizona  
 481 State University. The FDC is a unique public-private partnership with the goal to accelerate the  
 482 availability of the flexible display technology for the Soldier (FY04-FY13). Some of the results of  
 483 the FDC work, include demonstration of the world’s first flexible electrophoretic display (E-ink  
 484 Corporation) using the ASU patented bond-debond manufacturing process, development of the  
 485 ultra-large format flexible full color OLED displays (14.7” diagonal) and x-ray detector arrays  
 486 (FDC-Defense Threat Reduction Agency (DTRA) and the Palo Alto Research Center (PARC)), a  
 487 range of hand-held devices with an integrated flexible reflective displays (E-ink Corporation),  
 488 flexible reflective displays used in an Army field experimentations (Physical Optics Corporation)  
 489 and the fully flexible tablet for Soldier experimentations (Physical Optics Corporation), flexible  
 490 microelectromechanical systems (MEMS), among others [20]. Figure 12 illustrates an R2R  
 491 processed Silicon Radio Frequency Identification (RFID) chips. [21]  
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493  
 494 **Figure 12** - Silicon Radio Frequency Identification (RFID) chip with antenna processed using R2R technology [20].  
 495

- 496 • Further, starting in FY11, DTRA and ARL are collaborating on developing flexible digital x-ray  
 497 detectors using the display manufacturing process, although currently the manufacturing  
 498 process is plate to plate lithography, R2R is under consideration.
- 499 • A project with Hewlett-Packard (HP) and PowerFilms which was designed to advance plate to  
 500 plate and R2R, Self-Aligned Imprint Lithography (SAIL) process for display applications based on  
 501 amorphous silicon (Si) thin film transistor (TFT) arrays. Although the program was concluded  
 502 without any commercialization of technology in FY11, process feasibility was demonstrated.  
 503 Effort is now continuing via an ARL and FlexTech alliance focused on SAIL development.
- 504 • The ARL has investments through the FlexTech Alliance, a 30 industrial member consortium of  
 505 both domestic and international organizations. Their focus includes work on zinc-polymer  
 506 battery chemistries (referred to as Imprint Energy) that can be processed using screen printing  
 507 fabrication approaches. Using some of the more mature zinc-polymer chemistries, battery  
 508 process development has advanced enough to demonstrate prototypes which provide



509 reasonable performance. The effort also included TFTs and R2R processed OLEDs among others.  
510 The FlexTech Alliance also sponsored flexible Si complementary metal–oxide–semiconductor  
511 (CMOS) chips on paper, soldier health monitoring systems and other electronics designed to  
512 provide and enable prognostics and diagnostics. Many of these exploratory programs are at a  
513 Technology Readiness Level (TRL) 1-3. The paper-based flexible Si project is further advanced at  
514 a TRL 6 and Manufacturing Readiness Level (MRL) 3-4. This project represents a non-traditional  
515 flexible Electronic Manufacturing Services (EMS) program.

516

#### 517 **2.4.2. Current Research Efforts by DOE**

518 The DOE supports research and development (R&D) in the area of fuel cells, energy efficient buildings,  
519 solar energy, batteries and electric vehicles, advanced manufacturing technologies and fossil fuel energy  
520 as part of a broad portfolio of activities to secure the nation’s energy future.

521

- 522 • **The Fuel Cell Technology Office (FCTO)** develops fuel cells, which use fuels from diverse  
523 domestic resources to generate electricity efficiently, and hydrogen, a zero-carbon fuel when  
524 produced from renewable resources. These technologies comprise key elements of the DOE  
525 portfolio. Fuel cells address energy security by reducing or eliminating oil consumption in  
526 transportation energy generation applications. Fuel cell electric vehicles (FCEVs) operating on  
527 hydrogen from distributed natural gas can almost completely eliminate petroleum use. At 25%  
528 market penetration by 2050, FCEVs can reduce consumption of petroleum by more than 420  
529 thousand barrels per year (Mbbbl/yr) compared to 435 Mbbbl/yr consumed by the same number  
530 of internal combustion engine vehicles (ICEVs). Fuel cells can also provide highly reliable grid  
531 support; for example, during Hurricane Sandy, 22 of the 23 400-kilowatt (kW) United  
532 Technologies Corporation (UTC) Power (now ClearEdge Power) stationary fuel cells in New  
533 England and New York provided continuous power to buildings.

534

535 Assuming 15,000,000 fuel cell vehicles are manufactured per year (10% of the world market in  
536 2030), 4.5 billion membrane electrode assemblies per year produced at a rate of 11,700  
537 membrane electrode assemblies (MEA)/minute are needed for the fuel cell stacks. To achieve a  
538 quality requirement for MEAs of 0.1% stack failure, only one critical MEA failure in 300,000  
539 would be allowed; and for six sigma stack quality, only one critical MEA failure in ~90 million  
540 would be allowed. Quality control (QC) is critical and tools are needed. However, efforts like  
541 these exemplify an **“enduring economic benefit”** for both the public and commercial sectors.

542

543 As an example of R2R manufacturing challenges, Ballard Material Products (now AvCarb) was  
544 funded to develop a continuous mixing and coating process to manufacture gas diffusion layers  
545 for polymer electrolyte membrane fuel cells. Enhancements to the coating line included  
546 modified solutions (e.g. increase solids to reduce wet-load) and optimized dryer profile utilizing  
547 dew point sensors to prevent premature drying of the top layer. Using modified slot heights and  
548 a multilayer coating head, defect-free coatings and improved cross-web-basis weight uniformity  
549 resulted in successfully-produced defect-free anode and cathode materials. Improved  
550 repeatability of basis weights was achieved by installing Micro Motion flow meters for each  
551 solution. Issues still to address include formation of small agglomerates in the in-line ink due to  
552 solution modifications, trade-offs between modified solutions and mix quality, high amount of  
553 entrained air present with in-line ink, and examination of methods to improve a de-gas  
554 technique to remove air more efficiently, Bottom line is that gas diffusion layer (GDL) costs have  
555 been reduced over 50% since the start of the project and Manufacturing capacity has been  
556 increased nearly four-fold since the project began.



557  
558 There is a **“proper role of government”** in transitioning technology to the commercial sector.  
559 One example was through the DOE Market Transformation Appropriations and the American  
560 Recovery and Reinvestment Act (ARRA). DOE successfully deployed nearly 700 fuel cell material  
561 handling units with such customers as FedEx, Sysco, and Whole Foods. These deployments led  
562 to almost 5,400 industry funded and “on order” units with no DOE funding. The ARRA  
563 investment for these fuel cell powered lift trucks is about \$9.7M with an industry cost share of  
564 \$11.8M. ARRA support was used to demonstrate the commercial competitiveness of fuel cell  
565 backup power for telecommunications with over 820 fuel cell units and more than 80 units from  
566 Market Transformation Appropriations. As a result of government funding, sales of these  
567 technologies continue to grow without federal support with almost 3,600 industry-funded and  
568 “on order” fuel cell units for backup power.

569  
570 • **Solar Energy Technologies Office (SETO)** (through the SunShot Initiative) invested \$30 million  
571 (with 50% cost share matching) in establishing a consortium called the U.S. Photovoltaic  
572 Manufacturing Consortium (PVMC) in Albany, New York to support copper-indium-gallium-  
573 selenide (CIGS) photovoltaic (PV) products. Initially, a Manufacturing Demonstration Facility  
574 (MDF) was established for manufacture of CIGS on a steel web. US-based companies (Global  
575 Solar, MiaSole, NuvoSun and Ascent Solar) were interested; however, the dramatic price  
576 decrease of conventional crystalline silicon photovoltaics has led to several other U.S.-based R2R  
577 CIGS start-ups going out of business over the last two years. There has also been Asian  
578 acquisition of all the companies still in business in the United States (except NuvoSun).

579  
580 U.S. companies, still working in the CIGS R2R area, are not prepared to use the PVMC MDF and  
581 share what they consider to be proprietary processes in the context of a consortium. This is an  
582 example where “openness” was not a contributing factor. Public announcements indicate that  
583 these companies intend to scale in Asia and other developing nations. As a result, SETO has  
584 redirected the consortium to work on “downstream” issues in support of flexible CIGS, such as  
585 establishing the methods for installation of flexible PV modules and determining the reliability of  
586 flexible PV.

587  
588 • **The Building Technologies Office (BTO)** has a number of existing Investments in R2R  
589 manufacturing including architectural applications research with Lawrence Berkley National  
590 Laboratory (LBNL) regarding airflow panel membranes, with Oak Ridge National Laboratory  
591 (ORNL) in R2R sensors for building applications, with the National Renewable Energy Laboratory  
592 (NREL) investigating VI window film, with ITN Energy Systems and the Electric Power research  
593 Institute (EPRI) work on Low-energy/Electrochromic window film, with 3M/LBNL investigating  
594 daylighting film for windows, with 3M/ORNL (within the China Clean Energy Research Center  
595 (CERC) program) work focused on primer-less, self-adhered air sealing membranes, with  
596 PPG/Pacific Northwest National Laboratory (PNNL) developing infrared (IR) responsive window  
597 coatings, and with Heliotrope Technologies work on near IR Electrochromic (NIR EC) window  
598 coatings.

599  
600 **The Advanced Manufacturing Office (AMO)** (through prior programs supporting Inventions and  
601 Innovation as well as Industrial Sensors and Small Business Innovation Research (SBIR)) invested  
602 approximately \$1 million in cadmium-tellurium (CdTe) solar cell development and  
603 manufacturing; approximately \$1 million in advanced solar-reactive glazing, coating and  
604 manufacturing technologies to reduce unwanted solar gain through windows, skylights and

605 automotive windows; approximately \$1 million among battery technologies, super-capacitor  
 606 technologies, superconducting cable technologies; and approximately \$2M in advanced sensor  
 607 technologies. AMO investments focused on lithium-ion (Li-Ion) battery technology incorporating  
 608 R2R processing in the effort. A MDF has been established at ORNL with focus on electrolyte  
 609 materials used in laminated planar battery pack assemblies.  
 610

- 611 • **The Office of Fossil Energy (FE)** has investments concerning CO<sub>2</sub> membranes. Those involving  
 612 R2R manufacturing processes are being considered or used to manufacture several different  
 613 polymeric and ceramic/metallic membranes for CO<sub>2</sub> separation for power plants. Similar  
 614 processes are used to manufacture existing commercial water filtration and natural gas  
 615 processing membranes. FE has not been investing in the commercial production of membranes,  
 616 but rather left the commercialization of the materials to the project performers and their  
 617 partners. Issues such as defect control during coating and drying, substrate and active layer  
 618 bonding, and quality control/quality assurance (QC/QA) are consistent issues with  
 619 manufacturing CO<sub>2</sub> membranes. Many of the technologies are at the pilot scale and much of the  
 620 manufacturing processes efforts are considered at a similar scale of development (TRL 4-5). The  
 621 investments in membranes detailed in Table 2 for post-market and pre-market applications have  
 622 been made to date and may benefit from a concerted effort to improve the R2R manufacturing  
 623 processes.  
 624  
 625  
 626  
 627

Table 2 - Office of Fossil Energy Investments in CO<sub>2</sub> Membranes

Application	Company/Agency	Substrate	Active Layer	Type
Post	Ohio State University	Polymer - Polyethersulfone	Zeolites	Spiral Wound
Post	Membrane Technology & Research, Inc	Polymer	Polymer	Spiral Wound
Post	General Electric	Polymer	Phosphazene	Hollow Fiber
Post	Gas Technology Institute	Poly ether ether ketone (PEEK)	Perfluoro-oligimer	Hollow Fiber - Gas/Liquid
Post	Argonne National Laboratory	Alumina-Zirconia	Pd/TZ-3Y cermet	Long-tubes
Post	Pacific Northwest National Laboratory	Ceramic/Metallic	Ionic Liquid	Sheet/Plate
Pre	Praxair	Ceramic	Pd alloy	Shell and Tube
Pre	Eltron	Metal Alloy	Not Applicable	Shell and Tube
Pre	Worcester Polytechnic Institute	PSS-316L	Pd Alloy	Shell and Tube
Pre	Pall Corporation	Ziconia Coated SS Tubes	Pd Alloy	Shell and Tube
Pre	Los Alamos National Laboratory	Polybenzimidazole (PBI) - Polymer	PBI Polymer	Hollow Fiber

- 628  
 629 • **National Renewable Energy Laboratory (NREL)**  
 630 NREL efforts developed a defect diagnostic in house by applying a direct current (DC) potential  
 631 to a membrane electrode assembly and then monitoring the heat generated in the MEA using

632 an IR (heat) detector. Areas in which there is a defect generate no heat and no signal for the  
633 detector. NREL demonstrated the IR/DC technique on Ion Power’s production coating line for  
634 detection of electrode (on decal) defects.

635  
636 R&D at NREL is addressing quality control needs for scale-up of fuel cells and cell component  
637 manufacturing on weblines. The approach includes understanding quality control needs from  
638 industry partners and forums, developing diagnostics, using modeling to guide development,  
639 using in situ testing to understand the effects of defects, validating diagnostics in-line, and  
640 transferring technology to industry.

641  
642 • **National Science Foundation (NSF)**

643 NSF supports fundamental and translational research efforts within the Center for Hierarchical  
644 Manufacturing, an NSF-supported Nanoscale Science and Engineering Center (NSEC), leveraging  
645 \$4 million/year of federally-funded nanomanufacturing research, The research program focuses  
646 on the integration of nanofabrication processes for 30 nanometer and smaller elements based  
647 on directed self-assembly, additive-driven assembly, nanoimprint lithography, high fidelity 3-D  
648 polymer template replication, and conformal deposition at the nanoscale with Si wafer  
649 technologies or high-rate R2R-based production tools.

650  
651 NSF also supports fundamental and translational research efforts within the Nanomanufacturing  
652 Systems for Mobile Computing and Mobile Energy Technologies (NASCENT), an NSF-supported  
653 Engineering Research Center (ERC) leveraging \$4 million/year of federally-funded research on  
654 innovative nanomanufacturing, nanosculpting and nanometrology systems that could lead to  
655 versatile methods for the high-volume nanomanufacturing of mobile computing devices such as  
656 wearable sensors, foldable laptops and flexible batteries.

657  
658 • **Other**

659 Over the last 10 years, the European Union has had significant investments in R2R  
660 manufacturing and related printing plate-to-plate using organic based TFTs for displays and  
661 RFIDs. Some organizations involved, include: PlasticLogic (focused on plate-to-plate), POLYIC  
662 (involved in R2R RFID), and Philips and one of its subsidiaries, PolymerVision. The former  
663 company has recently introduced a range of flexible electronic OLED displays designed as  
664 “wearable” devices.

665  
666 Commercial alkaline battery manufactures focus on processes using R2R process techniques.  
667 Goal is to “build” structure, which includes “can” material, anodes and cathodes in a continuous  
668 process, with individual assembly achieved via a mechanical formatting operation at the end of  
669 the R2R process.

670  
671 The University of Massachusetts (UMass Amherst) within the Center for Hierarchical  
672 Manufacturing sponsors the “Research Cluster R: Roll to Roll Process Research Facility. The  
673 facility supports efforts focused on nano-imprint lithography (NIL) process and development.  
674 Current investment allows work up to 6-0inch wide format using a range of R2R equipment and  
675 analytical tools. Focus areas include; planarization, imprint embossing and patterning,  
676 alternative materials and membranes, functional hybrids, viscoelastic fluids, R2R integration and  
677 design for manufacturability.

678

679 The University of Kentucky Center for Applied Energy Research has a significant effort underway  
680 which focuses on a range of energy applications, some of which involve R2R. Areas of interest  
681 include low-cost carbon anode precursors, VRF, Thermoelectrics, etc.

682  
683  
684 Flexible “heater” circuitry for displays has been commercially available from companies such as  
685 All Flex Flexible Circuits, LLC for over 25 years. These products are fabricated using a mixture of  
686 R2R and batch “plate to plate” techniques, involving micro-electronics lithography printing and  
687 chemical etching processes.

688  
689 The Center for Advanced Microelectronics Manufacturing (CAMM), a partnership between  
690 Binghamton University (BU), Endicott Interconnect Technologies (EI), Cornell University and the  
691 Flex Tech Alliance, is a prototype R&D facility in large area flexible electronics. The CAMM is part  
692 of BU’s New York State Center of Excellence in Small Scale Systems Integration and Packaging  
693 (S3IP), which serves as an international resource for systems integration and packaging R&D.

694

## 695 **2.5. R&D in R2R Processing**

696

### 697 **2.5.1. Technological Needs of R2R Processing**

- 698 • **Providing a connection between emerging R2R process R&D and scaled manufacturing:** In  
699 order to extend R2R manufacturing technologies to volume manufacturing, several  
700 infrastructural needs must be established relevant to emerging processes and tools [1].
  - 701 ○ R2R manufacturing traditionally consists of coating and printing processes. While there  
702 are many companies engaged in R2R manufacturing, there remains a general lack of  
703 standardized infrastructure in some cases, and most academic institutions do not have  
704 R2R fabrication facilities. As a result, R&D data are still lacking on what are achievable  
705 with R2R processes and what are the limitations, especially in the context of throughput  
706 [1].
  - 707 ○ Parameters affecting throughput and defects control for various processes need to be  
708 established. In addition, the necessary supply chain is lacking, and needs to be broadly  
709 established, along with standards. Standards developments cannot be underestimated,  
710 and a more concerted effort in this area is necessary. One way to address these issues  
711 may be through the establishment of pilot line facilities for development,  
712 demonstration and optimization of full processes. This infrastructure component would  
713 provide a vital step between lab coupon-scale development and production line scale-  
714 up, ultimately reducing risk and cost, and providing a more rapid development path for  
715 product commercialization. This is due to the high cost of roll-to-roll instruments. This  
716 can be alleviated by creating shared facilities (such as the Research Cluster R for Roll-to-  
717 Roll Processing at UMass Amherst) that will be accessible for academics and for  
718 industrial participants to try out some ideas, as well as establish emerging processes and  
719 materials for broader use [1].
  - 720 ○ Previous DOE sponsored workshops [22] have identified a need to address equipment  
721 and quality issues. Equipment needs to support formats sufficient to meet nano-scale  
722 atomic layer deposition (ALD) and small-scale (e.g. microelectronics thin and thick-film)

726 to medium-scale (windows and window films) to large-scale (membranes for biofuel and  
727 natural gas processing) fabrication.

728 Investigations for manufacturing development should focus on tools to feed pre-  
729 requisite solutions, slurries at sufficient rates while controlling rheologies of these  
730 materials, webs (tensile strengths, surface finish and release, materials, zero defect,  
731 etc.), motor controls, motors (web speed control, tensioning, material “take-up”, post  
732 formatting, etc.), metrological instrumentation, simulation and design tools, control(s)  
733 feedback and adjust, materials drying accessories, ventilation and effluent treatments,  
734 incorporation of concurrent/simultaneous process using additive and subtractive, in-air,  
735 other atmosphere and vacuum processing, precision alignment, lithographic imaging  
736 and etch/deposition, etc.

737

- 738 • **Tackling challenges related to process tools and core capabilities:** [1] These include:
  - 739 ○ Large-area, cost-effective e-beam patterning tools/capabilities
  - 740 ○ Plasma etching tools for large-area, uniform R2R processing
  - 741 ○ Ink jet applicators compatible with wide range of UV monomers
  - 742 ○ Development of high-quality nickel metal electroforming processes for high aspect ratio,  
743 large pattern volume structures
  - 744 ○ High-durability, low-cost transparent imprinting of molds, or, inexpensive/fast  
745 replacement transparent molds
  - 746 ○ Fabrication of seamless cylindrical imprint molds
  - 747 ○ Large-area, real-time metrology and process characterization

748

- 749 • **Further developing emerging process tools towards large area processes:** [1]
  - 750 ○ Precision ink jet fluid applicators
    - 751 ■ Any dot, anywhere; high uniformity and thickness control
  - 752 ○ Atmospheric plasma etching
    - 753 ■ Lower-cost surface processing with elimination of vacuum step
  - 754 ○ R2R-ALD
    - 755 ■ Precision application of very thin layers at high rates
    - 756 ■ High conformality; uniform coating of aspect ratios up to 1000:1
    - 757 ■ High film density, low film stress
    - 758 ■ Continuous, pinhole-free ultra-thin films

759

- 760 • **Developing imprint and web materials:** [1] Materials are critical for the extension of R2R  
761 manufacturing processes to large area and high throughputs.  
762 In nanoimprint technology, the imprint materials need to be developed (especially for UV roll-  
763 to-roll imprint). There is also a limited supply of suitable web materials. Examples for a  
764 “materials wishlist” include:

- 765 ○ UV polymers that resist plasma crosslinking
- 766 ○ Transparent conductive polymers having:
  - 767 ■ Higher conductivity and light transmission
  - 768 ■ Improved durability/stability
  - 769 ■ UV curable
- 770 ○ Less costly, higher-temp substrates
  - 771 ■ (>250C; preferably clear...)

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- **Tackling metrology and instrumentation challenges:**

- Commercial enterprises which incorporate R2R into their product process routes have serious control issues regarding means to detect, control, and otherwise eliminate potential quality issues within products prior to investing additional value add. Cross-cutting needs include items such as; thickness measurement, inspection for mechanical defects such as pinholes and cracks, measurement of electrical properties such as resistance measurement of surface texture, structure and morphology, inspection for inter-layer delamination and voids, etc. Programs are highly desirable that generically investigate these issues with respect to differences in scale, criticality, application, ex-situ measurement while advancing tools and methods for the collection, analysis, storage, and use (either in real time or for later data mining) of high volumes of in-line QC data, and for the integration of these data into process control and feedback systems. Ultimately determinations of means to predict/correlate defects to performance would be one of the prime measurable program metrics.
- Defects are undesirable for printed electronics since they cause open and short circuits, thus destroying the performance of devices. There are several factors that cause defects such as missing nozzles in the print head, particles on the substrate, particles on the screen/stamp, web wander, non-uniform web tension, mis-registration, etc. A few examples of defects are shown in Figure 13.

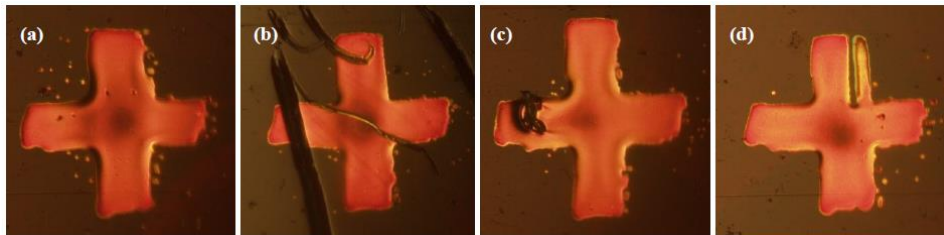


Figure 13 - Optical microscope images of (a) an intended pattern, and (b-d) show defects in the pattern [23]

- Metrology and inspection incorporating in-line optical techniques are presently being developed, but significant challenges remain for monitoring of high throughput processes having nanoscale features. In combination with this, model-based real-time diagnostics and control would complement the development of process modeling and control methods [1].
- For high rate R2R manufacturing, inspection and quality control is a critical area that determines successful outcome. These include defect detection, surface roughness measurement, inspection of layer quality, measurement of electrical properties to



- 821 ensure proper functionality, registration control, possibility for repair/correction,  
822 product testing, etc. [23].  
823
- 824 ○ Metrology and instrumentation challenges include availability of particulate-free high  
825 quality substrate, development and implementation of high-speed in-line and off-line  
826 inspection and diagnostic tools with adaptive control for patterned and unpatterned  
827 material films, development of reliable hardware, etc. These challenges need to be  
828 addressed and overcome in order to realize a successful manufacturing process. Due to  
829 extreme resolution requirements compared to print media, the burden of software and  
830 hardware tools on the throughput also needs to be carefully determined. Moreover, the  
831 effect of web wanders and variations in web speed need to accurately be determined in  
832 the design of the system hardware and software. [23]  
833
  - 834 ○ Realization of successful metrology and instrumentation by overcoming the challenges  
835 for the development of a R2R manufacturing system for flexible electronic systems  
836 opens limitless possibilities for the deployment of high performance flexible electronic  
837 components in a variety of applications including communication, sensing, medicine,  
838 agriculture, energy, lighting etc. [23].  
839
  - 840 ○ Metrology, standards and inspection requirements for R2R are [24]:
    - 841 ■ defect inspection-pattern defects
    - 842 ■ characterization/pattern inspection
    - 843 ■ laser scattering/particle size distribution
    - 844 ■ final yield as means to identify defects
    - 845 ■ cost involved for now at micron scale for adapting tools to R2R web platforms
    - 846 ■ smallest features inspected can reach to 1  $\mu\text{m}$ .
  - 847 ○ A summary of industry inputs on in-line QC techniques directly from EERE's Quality  
848 Control Workshop, which was held in 2013 in Golden, Colorado [22] are as follows:
    - 849 ■ Techniques currently used in industry to identify and quantify defects in  
850 materials are:
      - 851 ● Vision detection systems for cracks
      - 852 ● Fluorescence of functional coatings applied to textiles
      - 853 ● Non-contact eddy current measurements for surface sheet resistance
      - 854 ● Non-contact optical measurements for band gap and relative thickness  
855 of coatings
      - 856 ● Non-contact x-ray fluorescence (XRF) for composition and also thickness  
857 of coatings
      - 858 ● Photo-imaging for physical defects
    - 859 ■ Existing issues with the current quality assurance/quality control techniques
      - 860 ● Lack of standards. A few companies sell cameras and algorithms, but  
861 not necessarily tuned to the application
      - 862 ● Hardware exists. Main gap is software relevant to specific application
      - 863 ● Need to be able to scan for the composition of coatings (for multi-  
864 material coatings) and physical defects across full width and length of  
865 web while web is in motion
    - 866 ■ Measurements needed for in-line quality control that current techniques do not  
867 address

- 868 • Physical defect density and/or pinhole density
- 869 • Band gap measurements
- 870 • Surface sheet resistance of coatings
- 871 • Optical transmission
- 872 • Relative thickness of coatings across and along the length of the web
- 873 • Material composition measurements
- 874 • Networking-cloud data transmission

## 875 **2.6. Emerging Processes and Tools for R2R**

### 876 **2.6.1. Atomic Layer Deposition (ALD)**

878 ALD is a thin film deposition technique in which films are grown by the sequential pulsing of chemical  
879 precursors onto the surface of a substrate. A typical process sequence involves introduction of precursor  
880 A, followed by a system purge, then introduction of precursor B, followed by another system purge,  
881 after which the steps are repeated. The precursor reactions on the substrate surface lead to the growth  
882 of the thin film on a layer-by-layer basis, with the resulting film thickness controlled by the number of  
883 cycles of the process sequence. As the deposition process is self-limiting, the films are extremely  
884 uniform, pinhole free, and exceptionally conformal. ALD is capable of depositing a range of metal oxide  
885 films, as well as a limited number of metal coatings, and has the further advantage of relatively low-  
886 temperature processes and reasonably low-cost precursors for most applications. As a result, ALD is  
887 finding traction in the semiconductor industry, and has further been scaled to large-area substrate  
888 processes for thin film photovoltaics and displays where the metal oxide coatings yield superior barrier  
889 coatings and dielectric films [1].

### 890 **2.6.2. Potentiometric Stripping Analysis for Electroplated Alloys**

891 Electroplating represents an additive, solution-based deposition process suitable for R2R platforms for a  
892 range of metals and alloys. A key challenge for continuous, high-speed coating systems is the control of  
893 stoichiometry and the depletion the plating baths in web-based systems. The potentiometric stripping  
894 analysis (PSA) techniques precisely control both stoichiometry and uniformity of metal and alloy  
895 coatings on flexible webs. Keys to maintaining sufficient process control in the electroplating steps  
896 included keeping the solution at the work surface fresh and evenly biased by agitating the bath,  
897 providing adequate circulation, further utilizing an inert environment such as an argon blanket to  
898 minimize the effects of oxidation, and utilizing a separate anode for precise control of field distribution  
899 [1].

### 900 **2.6.3. High Temperature R2R Processes**

901 ORNL is conducting the research in the development of high-temperature R2R processes suitable to  
902 create crystalline, high-performance semiconducting materials. The high-temperature process capability  
903 can exceed 1200°C through the use of a high-temperature metal or suitable substrate; calendaring of  
904 thin film coatings then occurs, followed by a thermal pressing step. Because typical processes tailor a  
905 series of functional layers, inter-diffusion becomes a significant concern. This issue is resolved by  
906 depositing a stack of buffer layers to provide the required crystal orientation that include deposition of a  
907 diffusion barrier and then active layer coating. The high-temperature R2R processes can be used to  
908 develop hybrid solution-based approaches as well. The high-temperature processes are suitable for a  
909 range of thin film crystalline materials, including silicon for solar PV, diamond, and other  
910 semiconductors. This R2R process capability opens up opportunities for large-area, high-quality  
911 semiconductors having electronic transport properties approaching those of bulk materials, thereby  
912 enabling high-performance electronic devices and systems [1].

915

916

#### 2.6.4. Standards Development

917

918 Standards are an important aspect of the successful commercialization of any product, and typically are  
 919 underestimated. Benefits of standards include building end user confidence, creation of a common  
 920 language between producers and users, promotion of product compatibility and interoperability,  
 921 overcoming trade barriers to open markets, and fostering diffusion and adoption of technology. As  
 922 printed electronics and R2R manufacturing transcend from fundamental science to laboratory-scale  
 923 production platforms within academia and industry, the transition to pilot-scale production is hampered  
 924 by several factors that can benefit from standards. The resulting delay in the commercialization cycle  
 925 includes losses resulting from incoming materials variations, process technologies, process tolerances,  
 926 equipment and operator inconsistencies, and lot-to-lot variations, making it extremely costly and  
 927 difficult to scale to R2R production capacity [1].

928

### 2.7. Key Technology/Application Opportunity Areas

929

#### 2.7.1. Membranes

930

931 Areas of interest might include (but not limited to); high pressure “ceramic” membranes, indoor air  
 932 quality and dehumidification membranes for applications in buildings, other water processing, gas  
 933 separations for natural gas processing and CO<sub>2</sub> capture applications (CO<sub>2</sub>/N<sub>2</sub>, CO<sub>2</sub>, H<sub>2</sub>, and CO<sub>2</sub>/CH<sub>4</sub>), and  
 934 liquid/gas separation membranes (CO<sub>2</sub> loaded solvents), forward osmosis capacitive polarization  
 935 membranes, and other multilayer systems such as those used in battery applications, i.e. VRF which  
 936 support high permeability rates, resist reject material “buildup” and are environmentally “friendly”.  
 937 Current production cost of membranes is ~\$100/m<sup>2</sup>. Adapted manufacturing processes used by the RO  
 938 industry are needed to reduce costs by at least 50%. Current membrane market is \$16.5B globally –  
 939 United States demand is approximately \$1.7B total - Liquid separation is \$1.5B and ~\$0.15B for gas  
 940 separation. Expected to rise ~7% per year. Global membrane demand is expected to be \$25.7B in 2017  
 941 and continue to rise ~10% per year [25].

942

#### 2.7.2. Advanced Deposition Processes

943

944 Formatted, higher quality depositions are needed. Equipment needs to support formats sufficient to  
 945 meet microelectronics to building sector requirements. Investigations/development will focus on tools  
 946 to feed solutions and slurries at high rates while controlling solution rheologies; web properties, motor  
 947 controls for web speed control, tensioning, material “take-up”, post formatting; metrological  
 948 instrumentation; control feedback and process adjustment; materials drying; ventilation and effluent  
 949 treatments, and incorporation of concurrent/simultaneous processes. Emphatically, all of the  
 950 aforementioned is needed at all-size scales, i.e. from the nano/atomic scale through thin-film to thick-  
 film size-scale.

951

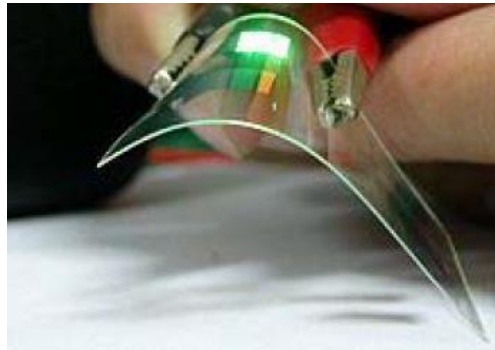
#### 2.7.3. Flexible Electronics

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953 An intriguing space is R2R additive manufacturing for EMS. The technology applications are well defined,  
 954 most of the materials are well defined in manufacturing, mostly the technologies, with exception of  
 955 interconnects that are mature (MRL 4-5). However, government investments are necessary to reduce  
 956 risk for industry to participate. EMS is a \$300B/year industry. The market is in printed circuit board  
 957 population with Si CMOS and passive components. On a limited basis, R2R is used in single chip  
 958 integration for smart labels (RFID tags and antennas), such as products offered by Muhlbauer High Tech  
 959 International [26]. Another area of possible manufacturing development involves OLEDs which can be  
 960 processed on flexible substrates [27], as shown in Figure 14. Systems have been developed which have  
 961 exhibited a brightness as high as 10,000 candela per square meter. DOE projects the benefits of  
 replacing traditional systems with phosphorescent OLED lighting, in the time frame of 2012 to 2018, as

962 reducing energy use by 0.22 quadrillion Btu’s, saving domestic consumers \$20 billion and reducing  
963 environmental pollution emissions by 3.7 million metric tons [28].

964



965 **Figure 14** - Demonstration of a flexible OLED device. Photo: General Electric

966  
967

968 The second area of interest focuses on larger format flexible displays, detectors and other sensors, such  
969 as used for neutron and other E-M arrays. This path will be to move from plate-to-plate standard  
970 lithography as used in the industry to continuous R2R processing. This approach leverages \$90M of  
971 existing U.S. Army investments, and \$1T+ of industrial private sector investments in traditional flat-panel  
972 glass manufacturing. The current TRL levels are 3-4 for emerging applications, TRL 5-6 for the maturing  
973 flexible digital x-ray technology. The MRL level is 5, with development necessary to broaden the  
974 application space, reduce cost and improve yield. Here the work would attempt to merge traditional  
975 processes with some R2R technology. If a major thrust involves sensors, opportunity to continue  
976 development of materials (incorporating new material sets, enhanced efficiency of traditional types, i.e.  
977 substitutional elements, enhanced process, etc.) will be investigated. Sensor efforts include from  
978 MRL/TRL 1 to fully commercialize. Those efforts within the MRL/TRL 4 to 7 include those that would  
979 serve to incorporate program information to feed MetaData collection, design of more  
980 efficient/selective devices, develop imbedding processes within other materials-assemblies, means to  
981 enhance signal processing, and collected data “Cyber Security”. This latter being needed as users will  
982 need to collect data remotely to gage quality, state-of-the condition to enable state of process or mean-  
983 time to failure, response characterization, etc. via the “internet cloud” to be successful. If one considers  
984 thin-film MEMS sensors and devices within the scope of this sector, the market could exceed \$1 trillion.

985

986 A third area would be to focus on the advancement of materials with associated equipment to enable  
987 commercialization of NIL and patterning with 50 to 100nm print resolution at process rates of 3 to 5  
988 meters per minute. Fourthly, flexible electronics need to include investigation of lighting technologies.  
989 This would include moisture and environmental barrier materials/layers with ALD of LED and OLED  
990 technologies with associated packaging systems, which are fabricated in multilayer fashion to achieve a  
991 hermetic, moisture-proof package.

992

993 The current research work is focused on the following topics: [29]

994

995 • Developing roll-to-roll manufacturing of thin film electronics on low-cost flexible substrates  
996 using Pulse Thermal Processing (PTP) technologies coupled with non-vacuum low temperature  
deposition techniques.

997

998 • Developing non-vacuum, large scale deposition and processing techniques for nanoparticle-  
999 based inks and pastes that reduce cost and energy requirements associated with processing of  
thin film electronics.

- Ink development and annealing studies to increase the crystallinity and photo luminescent efficiency of Zinc-Gallate coatings.

#### 2.7.4. Battery Technology

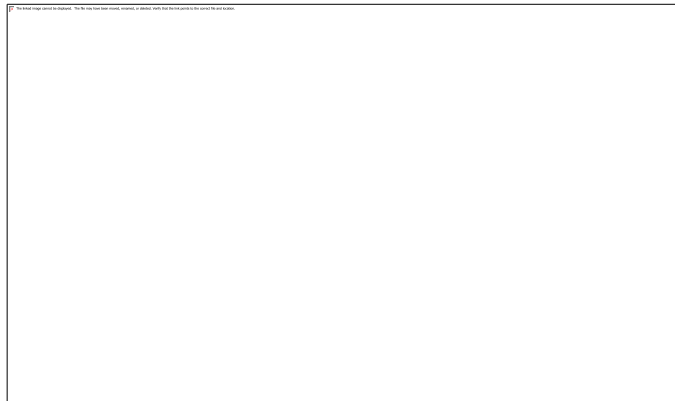
Including existing agency investments and commercial development results, work should focus on a wide range of battery chemistries, i.e. Li-ion, Zinc-polymer, Li/CFx, Vanadium Redox Flow (VRF) systems, and advanced alkaline systems. Continuous materials deposition on webs to build the “multi-layer” configuration using tape cast, screen print, vapor or wet chemical deposition or evaporative/sputter techniques could be included. Of special interest would be deposition of carbon nano-tubes and whiskers on graphene for certain applications.

The current research work to apply R2R processes in flexible thin-film battery manufacturing is focused on the following topics: [30]

- Reducing excessive scrap rates of electrode coatings.
- In-line quality measurement and control – For example: In-line laser sensing for thickness monitoring, in-situ materials diagnostics with ex-situ structural characterization.
- Reducing manufacturing as well as associated system cost by implementing in-line Non-Destructive Examination (NDE) and QC].
- Scaling-up, Industrial issues of yield and throughput.

#### 2.7.5. PEM Fuel Cells

The manufacture of fuel cell stack components utilizing continuous, high volume, lower cost process technologies is needed. Current R2R technology and methods need to replace the manual preparation of layers, such as painting catalyst ink by hand onto decals that are then thermally pressed onto membranes. The process should also address high-speed sealing of assemblies which can be accomplished using R2R processes. Figure 15 shows an approach that WL Gore & Associates [31] is working on to coat electrodes directly onto membrane material saving steps and material thus saving money.



**Figure 15** - Approach to coat electrodes directly onto membrane material saving steps and material

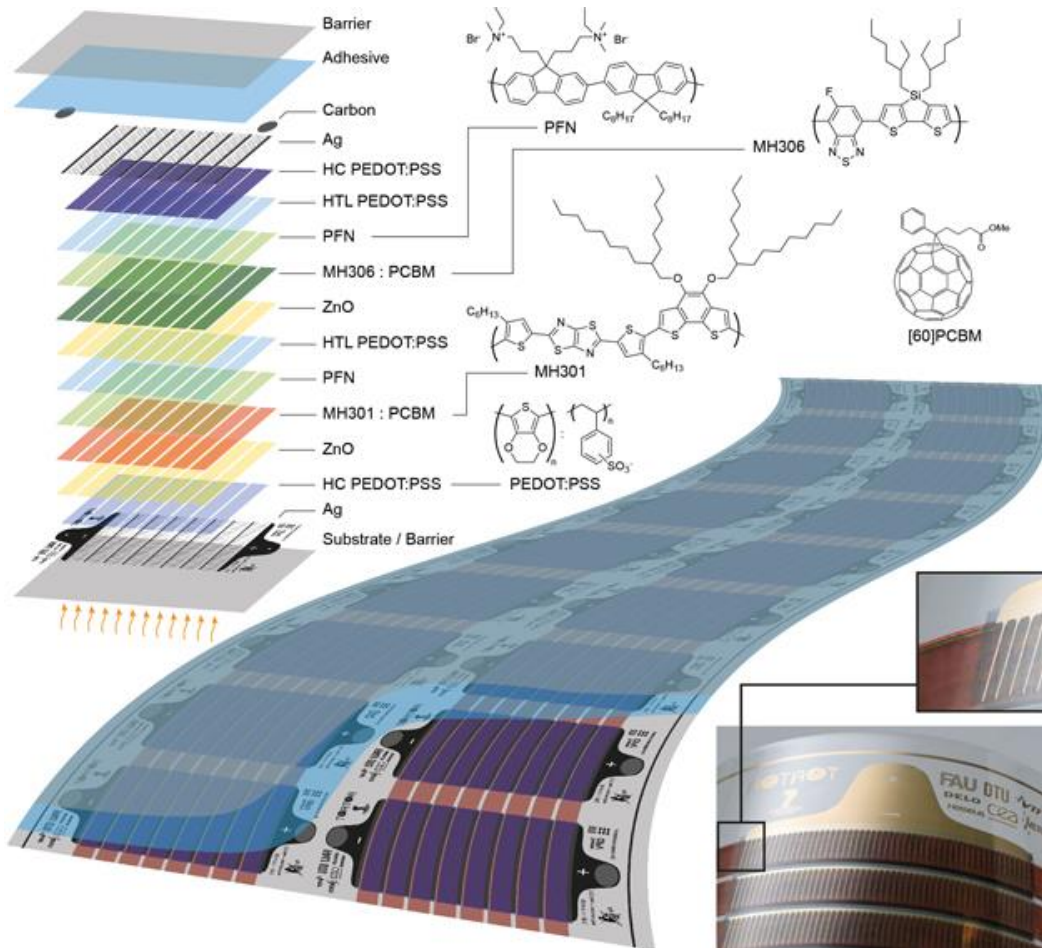
In 2012, the domestic fuel cell and hydrogen energy industry was expected to produce \$785 million in revenue [32]. Funding from DOE EERE for hydrogen and fuel cell R&D has played a critical role to enable this emerging fuel cell industry. According to Bloomberg New Energy Finance [33], DOE funding was approximately equal to venture capital and private equity investment in the United States in 2011. EERE funding has led to more than 450 patents, 40 commercial technologies, and 65 emerging technologies for hydrogen production and delivery, hydrogen storage, and fuel cells.



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**2.7.6. Photovoltaics**

- In addition to efficient processing, efficient process control during manufacture is required, and new materials and processes are urgently needed. Some of the most important materials and processes are those that will enable the printing of semitransparent electrodes and complete processes that are built around enabling complete fabrication of efficient solar cells. The materials and processes should of course give access to organic photovoltaic (OPVs) that provide operational stability of more than 10 years and they should be efficient (> 10 %). A particular requirement to the OPV is that it has as thin an outline as possible with low materials consumption, to achieve a low embodied energy. The processing should not be environmentally harmful and should, through use of the lowest possible temperatures, require a very low input energy for manufacture. This will enable short energy payback times. Manufacture of the entire solar cell stack at an overall speed of > 10 m/min will enable the manufacture of a daily energy production capacity of more than 1 gigawatt peak and thus, in principle, fully address mankind’s future energy needs [34]. Figure 16 illustrates the assembly of a scalable, encapsulate, large area, flexible, organic solar cell produced by a R2R process. [35]



**Figure 16** - Scalable, ambient atmosphere roll-to-roll manufacture of encapsulated large area, flexible organic tandem solar cell modules [35].



- 1072 • The scientific thrust should be with the final form and processing methods in mind and not as it  
1073 has been until now with a blind focus on high performance in an often unrealistic and not  
1074 scalable setting [35].  
1075
- 1076 • The active materials and inks needs to be developed specifically with the thermo-mechanical  
1077 properties of the multi-layer structure in mind. The complex multi-layer structure with different  
1078 thermal expansion coefficients and moduli for the individual layers and different adhesion  
1079 energies at each interface are likely to present an enormous challenge for the manufacture of a  
1080 robust flexible tandem organic solar cell [35].  
1081
- 1082 • Research efforts are needed on the control of film thickness and especially the evenness of the  
1083 dry films for the multi-layer stack through proper ink design. This involves control of viscosity,  
1084 ink stability over time, ink rheology during deposition, ink rheology during drying (i.e. heating  
1085 and up-concentration of solutes in the wet film), wetting behavior during deposition and drying,  
1086 control over morphology formation and of course it must all work in air [35].  
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#### **2.7.7. Metrology and Quality Systems**

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- Commercial enterprises which incorporate R2R manufacturing into their processes must detect, control, and otherwise eliminate potential quality issues within products.

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- Technology development needs include inspection for mechanical defects such as pinholes and cracks, measurement of electrical properties such as resistance measurement, and inspection for inter-layer delamination and voids.

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- All data would be integrated into process control and feedback systems. These technologies will be used to correlate defects to performance.

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##### **2.4.1.1. Embedded Thermal Energy**

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- There is a need to develop R2R additive manufacturing for electronics applications such as larger format flexible displays, detectors, and stretchable/conformable sensors.

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- This technology will lead to a fundamental change for manufacturing these systems from plate-to-plate standard lithography to continuous R2R processing.

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## **2.8. Technology Roadmaps Applicable to R2R Manufacturing**

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R2R is a type of process, not a technology, and therefore no specific technology roadmap exists for developing R2R processes in general; instead, roadmaps exist for specific technologies that would use a R2R process as the manufacturing method. R2R processes can be improved by insertion of technologies that make the process more efficient and less costly. The International Electronics Manufacturing Initiative (iNEMI) developed a technology roadmap for flexible electronics that addresses materials (nanoparticle suspensions, particle blends, and small molecular solutions), printing technologies (contact and non-contact), and processes (roll to roll, roll to sheet, and sheet). [36] In the United Kingdom, the Centre for Process Innovation developed their technology roadmap to expand R2R and encapsulation processing technologies to target the development of flexible optoelectronic devices for the emerging

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1117 printed electronics markets and to address many of the challenges encountered in scaling up emerging  
1118 technologies to commercialization by adopting R2R processing techniques.[37]

1119 From an industry perspective, Baker™ Wet Process Equipment has developed a technology roadmap to  
1120 understand and manage the issues associated with conventional versus R2R processing for  
1121 manufacturing flexible printed circuits. [38] Their roadmap focuses on the core of current manufacturing  
1122 trends toward producing thinner, lighter and higher density printed circuits by use of effective handling  
1123 and processing of a thin core material. R2R processing equipment will need to focus on the smooth, yet  
1124 firm, transport of films through various wet processes in both a horizontal and vertical plane and will  
1125 require “next generation” spray- or immersion-type technologies. Flexible printed circuit fabrication  
1126 using batch processing and antiquated rigid-panel processes is responsible for the failure to produce the  
1127 necessary technologies in the last century and will be superseded by R2R technology in the future. [39]  
1128 Additionally, the National Aeronautics and Space Administration (NASA) has drafted integrated  
1129 technology roadmaps for 14 Space Technology Areas, which includes “pull” and “push” technology  
1130 strategies and considers a wide range of pathways to advance their current capabilities in space.  
1131 Technology Area 12 addresses materials, structures, mechanical systems, and manufacturing. Although  
1132 R2R is not specifically addressed as part of the roadmap, several of the technologies and processes, such  
1133 as hybrid laminates, polymer matrix composites, multi-functional thin films, flexible materials for entry-  
1134 descent-landing, photovoltaics, lightweight aluminized thin film systems for solar sails and large ultra-  
1135 light precision optical materials are all directly applicable to R2R manufacturing.[40]

### 1136 **2.9. Workshops on R2R Processes and Manufacturing**

1137 Workshops are not held specifically on just R2R manufacturing. Usually a workshop is convened on a  
1138 technology area such as Nanofabrication Technologies for R2R Processing [second ref] or the DOD and  
1139 DOE Manufacturing Innovation Topics Workshop [third ref] where R2R manufacturing is an agenda topic  
1140 or a separate breakout session. Discussions typically focus on using a R2R process for coating of polymer  
1141 films, device level patterning, imprint lithography methodology, patterning limitations, and NIL for R2R  
1142 processing of nanotechnologies.[1] Workshops also address programmatic issues for R2R manufacturing  
1143 such as R2R process technology needs; manufacturing challenges, and investments; process deficiencies  
1144 and metrological needs; and quality systems and synergy. [41] Workshops are held annually on  
1145 nanomanufacturing that provide opportunities to share information on emerging processes and scaled  
1146 manufacturing platforms where R2R may have a role. [42] [43] They can also focus on specific  
1147 technology areas that have immediate applications to clean energy initiatives such as biomass indirect  
1148 liquefaction that focuses on pathways that convert biomass-based synthetic gases to liquid  
1149 intermediates. [44] Inevitably, the common areas of interest lie in overall technology needs,  
1150 manufacturing challenges, and investment levels.

1151

## 1152 **3. Risk and Uncertainty, and other Considerations**

1153

### 1154 **3.1. Risks and Uncertainties of Using R2R Processes and Manufacturing**

1155 The risks with using R2R processes are defined in the challenges. R2R manufacturing is not ideal for  
1156 every type of material manufacturer, but it is ideal for thin and thick film materials with large areas that

1157 are required for high volume production with minimal defects and waste. R2R processes, in general, are  
1158 energy efficient and environmentally friendly. However, as with any type of manufacturing, there are  
1159 associated risks and uncertainties.

1160 • **High Startup Costs** - A combination of high costs and poor availability of production tools are  
1161 hindering the adoption of roll-to-roll manufacturing. For example, setting an active-matrix  
1162 flexible organic light-emitting diode (OLED) substrate line amounted to roughly \$177 per square  
1163 foot. The cost of tooling a passive-matrix polymer light-emitting diode (PLED) line is far less, at  
1164 \$45 per square foot. Still, the long-term promise of roll-to-roll manufacturing is propelling it to  
1165 the forefront of flexible substrate R&D activity. The Center for Advanced Manufacturing  
1166 (CAMM), Binghamton, NY expanding its tooling capability to actively research R2R  
1167 manufacturing for emerging technologies such as large-area LED lighting, photovoltaic cells on  
1168 plastic, low-cost RFID tags, and lightweight electronics and packaging platforms on rugged,  
1169 flexible substrates. Also, scientists at Hewlett-Packard Laboratories and Iowa, Thin Film  
1170 Technologies, are developing large-area arrays of thin-film transistors on polymer substrates  
1171 using R2R techniques. The approach combines plasma deposition and etching with self-aligned  
1172 imprint lithography to produce a cost effective end product. [45] Further research in specific  
1173 applications that employ R2R processes will provide the data needed to reduce the costs of  
1174 startup.

1175  
1176 • **Speed of High Volume/Large Area Process vs Low Volume/Small Item Stand-Alone Process** -  
1177 The speed and capacity for R2R manufacturing versus a batch process is dependent on the  
1178 material requirements for the end product and is directly related to costs. As an example, if an  
1179 assumption is made that conventional operations such as lithography, etching and sputter  
1180 deposition are used in the R2R process, and 1000-foot by two-foot rolls of polymeric substrate  
1181 are used to make a final product of 3.25-inch by 3.25-inch LED display on an 18-inch by 24-inch  
1182 format, then the cost per square foot of active and passive matrix displays are expected to  
1183 decline with increases of volume. Indeed, studies have shown that the minimum efficient scale  
1184 for the operation of a R2R display manufacturing facility is around 20,000 square feet per week.  
1185 Many markets and application areas could support a plant operating at this capacity if the  
1186 displays could be sold into these markets at a sufficiently high volume to sustain the  
1187 manufacturing operation. If the plant operated at a capacity of 100,000 square feet per week  
1188 over a two-year period, the cost of producing LED displays would be about half the cost of a  
1189 display produced by a conventional stand-alone batch manufacturing approach. Nearly every  
1190 model in the display industry predicts that a R2R manufacturing facility could offer significant  
1191 cost savings if it can be integrated successfully. [46]

1192  
1193 • **Material Variations/Tolerances/Lot Variations/Scrap** - Variations in substrates and production  
1194 lots of the end products from R2R manufacturing can be caused by several factors depending on  
1195 the materials being used, the machinery involved, the control of the web, and the process(es)  
1196 employed (lithography, deposition, etc.) just to name a few. Even the configuration of the rollers  
1197 (double side mounted or cantilevered) will produce variations. In some applications such as thin

1198 films and nano-materials, the tolerances must be closely controlled in order to get a quality end  
1199 product. If tolerances and variations are significant, then the R2R process can result in a lot of  
1200 scrap and waste material that may not be recyclable. This also adds to the cost of manufacture.  
1201 As the R2R process becomes more adapted to the anomalies in the initial production phases, the  
1202 material and lot variations are usually reduced and the end products are well within tolerances.  
1203 Research is needed on various types of instruments can be incorporated into the R2R process to  
1204 further reduce variations and eliminate scrap.

1205

- 1206 • **Metrology** - As previously discussed in this section, the success of employing a R2R process in  
1207 manufacturing a specific technology is heavily dependent on process and cost control. At high  
1208 rates of R2R manufacturing, metrology is needed to address defects (from static buildup and  
1209 missing or disconnected patterns), quality of substrate, registration (pattern position), and in-  
1210 line and off-line optical inspection for quality control. [47] This can go beyond just looking for  
1211 material defects such as pinholes, non-uniform thickness, and impurities. As an example, at the  
1212 end of processing polymer solar cells using roll-to-roll methods, one ends up with a roll of  
1213 material. While some testing can be carried out during the processing of the individual layers,  
1214 the functionality of the solar cell itself, i.e., the production of electrical energy upon being  
1215 subject to illumination, has to be carried out at the very end, on the very roll that is the end  
1216 product. Inline monitoring techniques are useful for guiding the process, but they cannot  
1217 guarantee the final performance. Therefore R2R instrumentation is also needed to test  
1218 functionality. The techniques that have proven useful for process control are the camera  
1219 techniques, providing two-dimensional information using transmission, reflection, and dark field  
1220 imaging of the printed or coated films, and revealing detail on film thickness variations,  
1221 registration, and particle detection. These techniques are non-contact techniques and apply to  
1222 individual layers during manufacture. Methods such as light beam induced current mapping,  
1223 dark lock-in thermographic imaging, electroluminescence imaging, and photoluminescence  
1224 imaging are being used successfully today in R2R manufacturing of solar cell materials. [48]

1225

1226 DOE’s Manufacturing Demonstration Facility (MDF), established at ORNL, provides unique  
1227 capabilities to assist industry in adopting new manufacturing technologies to reduce life-cycle  
1228 energy and greenhouse gas emissions, lower production cost and create new products and  
1229 opportunities for high paying jobs. [49] The MDF can be a tremendous asset in addressing the  
1230 above risks and uncertainties.

1231

- 1232 • **Proprietary Information and Intellectual Property** – Successful implementation of R2R  
1233 processes within the manufacturing industry will require information exchange, resource  
1234 partnering, open discussion of ideas, discoveries, and best practices. Key challenges exist in  
1235 providing an open forum for networking while protecting the proprietary information and  
1236 intellectual property of the community

1237

- 1238 • **Technology Characteristics That Impact Policy**

1239  
1240 The President’s 2012 *National Strategic Plan for Advanced Manufacturing* emphasized the need  
1241 for increased R&D on advanced materials and innovative manufacturing technologies that have  
1242 the potential to reduce U.S. manufacturing energy use while enhancing product quality and  
1243 shortening design cycle times. [50] DOE is responsible for executing programs resulting in the  
1244 development of competitive new manufacturing processes for U.S. industry to provide state-of-  
1245 the-art technologies in advanced vehicles, biofuels, solar energy and other clean energy  
1246 technologies. Technologies areas, such as advanced lightweight materials, membranes and TFTs,  
1247 have an immediate use for improving products for clean energy applications and are  
1248 appropriate for manufacturing using R2R processes.  
1249

## 1250 4. Sidebars: Case Studies

### 1251 1252 4.1. Thin-Film Solar Cell Efficiency Record Set By First Solar (Again) [51] [52]



1253  
1254 **Figure 17** - First Solar, Inc. Solar Cell Array

1255 Working with DOE National Renewable Energy Laboratory (NREL), First Solar, Inc. set a world record in  
1256 2013 for CdTe PV solar cell conversion efficiency, achieving 20.4 percent conversion efficiency. The U.S.-  
1257 based company recently announced that a cell manufactured at its manufacturing factory and R&D  
1258 center achieved an efficiency of 21%, the highest on record by a non-concentrating cadmium-telluride  
1259 (CdTe) cell. Improvement in CdTe PV performance was demonstrated at a rate that dramatically  
1260 outstrips the trajectory of conventional multicrystalline silicon technologies, which have already  
1261 plateaued near their ultimate capabilities. First Solar, Inc. has also gone a notch up on multi-crystalline  
1262 silicon cells, whose efficiency peaked at 20.4% in 2004.

1263 The encouraging fact about the cell is that it has been constructed using processes, such as roll-to-roll,  
1264 and materials designed for commercial-scale manufacturing, thus making it possibly easier for First Solar  
1265 to quickly switch to the cell’s mass production.



1266 First Solar, Inc. also synergy realized a synergy by partnering with GE Global Research in 2013 with  
1267 consistent and strong investments in R&D. The advanced technologies and processes developed for the  
1268 CdTe PV solar cell are already being commercialized and will positively impact performance of future  
1269 production solar cell modules and power plants.

1270 First Solar has continued to transfer success in R&D into commercial modules, increasing its average  
1271 production module efficiency to 13.4 percent in the fourth quarter of 2013, up 0.6 percent from 12.9  
1272 percent in the fourth quarter of 2012. The company's lead line was producing modules with 13.9  
1273 percent average efficiency at the end of 2013. [51]

1274 **4.2. Commercial Buildings Integration of Energy Saving Window Coatings [52] [53]**



1275  
1276 The DOE Building Technologies Office (BTO) works with the commercial building industry to accelerate  
1277 the uptake of energy efficiency technologies and techniques in both existing and new commercial  
1278 buildings. By developing, demonstrating, and deploying cost-effective solutions, BTO strives to reduce  
1279 energy consumption across the commercial building sector by at least 1,600 TBtu. [52] The BTO has  
1280 several projects in R&D for electrochromic windows, high-insulating windows, and nano-lens window  
1281 coatings for daylighting and low-e storm windows adoption. [53] R2R manufacturing is used for products  
1282 like 3M™ window films block up to 60% of the sun’s heat. Transparent, rather than dark or shiny, costs  
1283 of cooling are saved without sacrificing passive lighting or views. [54]

1284

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1286

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